

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Padiyar, et al.

Application No.: 10/816,019

Filed: March 31, 2004

For: LIGHT SOURCE FOR
PHOTOLITHOGRAPHY

Examiner: Nguyen, Hung

Art Unit: 2851

Confirmation No.: 2653

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY UNDER 37 CFR §1.116 EXPEDITED PROCEDURE

Dear Examiner:

This is in response to the Final Office Action mailed April 20, 2009. Applicants respectfully request the Examiner to enter this response and consider the following remarks.

The Listing of Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

I hereby certify that this correspondence is being deposited via
EFS Web on the date below:

June 22, 2009

Date of Deposit

/Gigi Hoover/
Gigi Hoover